

TECHNICAL SPECIFICATION

Safety of laser products -
Part 13: Measurements for classification of laser products

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**Safety of laser products -
Part 13: Measurements for classification of laser products**

FOREWORD

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IEC TS 60825-13 has been prepared by IEC technical committee 76: Optical radiation safety and laser equipment. It is a Technical Specification.

This first edition cancels and replaces the second edition of IEC TR 60825-13 published in 2011. This edition constitutes a technical revision.

This edition includes the following significant technical changes with respect to IEC TR 60825-13:2011:

- a) minor changes and additions have been made in the definitions;
- b) classification flow has been updated;
- c) apparent source sections have been clarified;
- d) scanning has been updated;
- e) more examples and useful conversions have been added to the annexes.

The text of this Technical Specification is based on the following documents:

| Draft | Report on voting |
|------------|------------------|
| 76/786/DTS | 76/791/RVDTS |

Full information on the voting for its approval can be found in the report on voting indicated in the above table.

The language used for the development of this Technical Specification is English.

This document was drafted in accordance with ISO/IEC Directives, Part 2, and developed in accordance with ISO/IEC Directives, Part 1 and ISO/IEC Directives, IEC Supplement, available at www.iec.ch/members_experts/refdocs. The main document types developed by IEC are described in greater detail at www.iec.ch/publications.

This document is to be used in conjunction with IEC 60825-1:2014.

A list of all parts of the IEC 60825 series, published under the general title *Safety of laser products*, can be found on the IEC website.

The committee has decided that the contents of this document will remain unchanged until the stability date indicated on the IEC website under webstore.iec.ch in the data related to the specific document. At this date, the document will be

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